

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **Divisional** Application of )  
Shunpei YAMAZAKI et al ) Art Unit: 2818  
Based on U.S. Serial No.: 09/466,828 ) Examiner: Renee R. Berry  
Which was Filed: December 20, 1999 )  
For: INSULATING FILM AND METHOD OF )  
PRODUCING SEMICONDUCTOR DEVICE ) Date: March 1, 2002



#4  
IOS  
Sheresa  
6/6/02

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

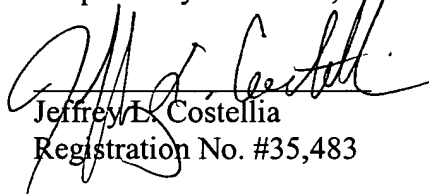
Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

The references listed on the attached Form PTO-1449 were cited in parent application Serial Nos. 09/466,828 filed December 20, 1999, and the predecessor application Serial Nos.: 09/190,828, 08/734,127, 08/445,575, 08/198,054.

Respectfully submitted,



Jeffrey L. Costellia  
Registration No. #35,483

Nixon Peabody LLP  
8180 Greensboro Drive, Suite 800  
McLean, Virginia 22102  
(703) 790-9110

JLC/sas